



Docket No.: 060188-0660

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Toshikazu ONISHI

RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE

Application No.: 10/665,469

Customer No.: 20277

Filed: September 22, 2003

Confirmation No.: 5515

Group Art Unit: 2828

Examiner: Phillip Nguyen

Title: SEMICONDUCTOR LASER DEVICE AND METHOD FOR FABRICATING THE  
SAME

**AMENDMENT UNDER 37 CFR 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

*please enter  
PN  
1/26/07*

Sir:

The following Amendment and Remarks are submitted in response to the Office Action  
dated September 26, 2006, pursuant to the provisions of 37 C.F.R. § 1.116.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this  
paper.

**Remarks** begin on page 7 of this paper.